STATES PATENT AND TRADEMARK OFFICE

In re the Application of: NAKATA, Yoshihiro et al.

Group Art Unit: 1771

Serial No.: 10/807,174

Examiner: Hai VO

Filed: March 24, 2004

P.T.O. Confirmation No.: 4205

SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM, For. SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW DIELECTRIC CONSTANT FILM

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: October 29, 2007

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated June 4, 2007, for two months, from September 4, 2007, to November 4, 2007.

Please charge our Deposit Account No. 01-2340 in the amount of \$460.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, ØUNTOS & HANSON, LLP

Daniel A. Geselowitz, Ph.D.

Agent for Applicant

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PATENT & TRADEMARK OFFICE

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Atty. Docket No. 011293A Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930